#20 9/17/03 Nouish

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Inventor(s)

Teiichirou Chiba et al.

Serial Number

09/492,761

Filed

January 27, 2000

For

SEMICONDUCTOR WAFER

Examiner

Chris C. Chu

**FAX RECEIVED** 

Group Art Unit

2815

SEP 1 1 2003

**TECHNOLOGY CENTER 2800** 

Submitted by Facsimile Facsimile No. 703-308-7722

## RESPONSE AFTER FINAL UNDER 37 C.F.R. § 1.116

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 11, 2003

Dear Sir:

The following remarks are submitted in response to the Official action mailed June 11, 2003. The Official action set forth a three-month period for response, making this response due on or before September 11, 2003.